

**Amendments to the Specification**

Please replace the paragraph beginning on page 1, line 3, with the following rewritten paragraph.

This application claims priority to U.S. Provisional Application No. 60/396,197 entitled “Qualifying Patterns, Patterning Processes, or Patterning Apparatus in the Fabrication of Microlithographic Patterns,” filed July 15, 2002, which is incorporated by reference as if fully set forth herein. This application also claims priority to U.S. Provisional Application No. 60/      ,      /485,233 entitled “Qualifying Patterns, Patterning Processes, or Patterning Apparatus in the Fabrication of Microlithographic Patterns,” filed July 7, 2003, which is incorporated by reference as if fully set forth herein.